



Technical Goals in TD Phase

技術設計段階での技術開発・ハイライト

- SCRF Technology (超伝導・ビーム加速技術)
 - Cavity: High Gradient R&D:
 - 35 MV/m with 50% yield by 2010 , and 90% by 2012 (TDR)
 - Manufacturing with cost effective design
 - Cryomodule performance including HLRF, and LLRF
 - Beam Acceleration
 - 9 mA: FLASH
 - 1 ms: STF2 - Quantum Beam
- Nano-beam handling (ナノビーム技術)
 - ILC-like beam acceleration
 - Ultra-low beam emittance: Cesr-TA, ATF
 - Ultra-small beam size at Final Focusing: ATF2

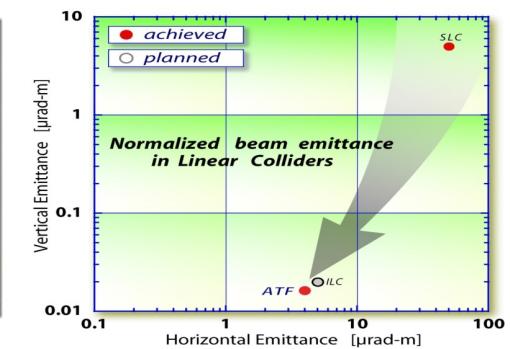
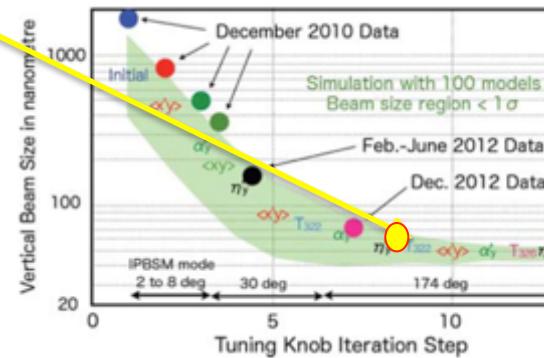
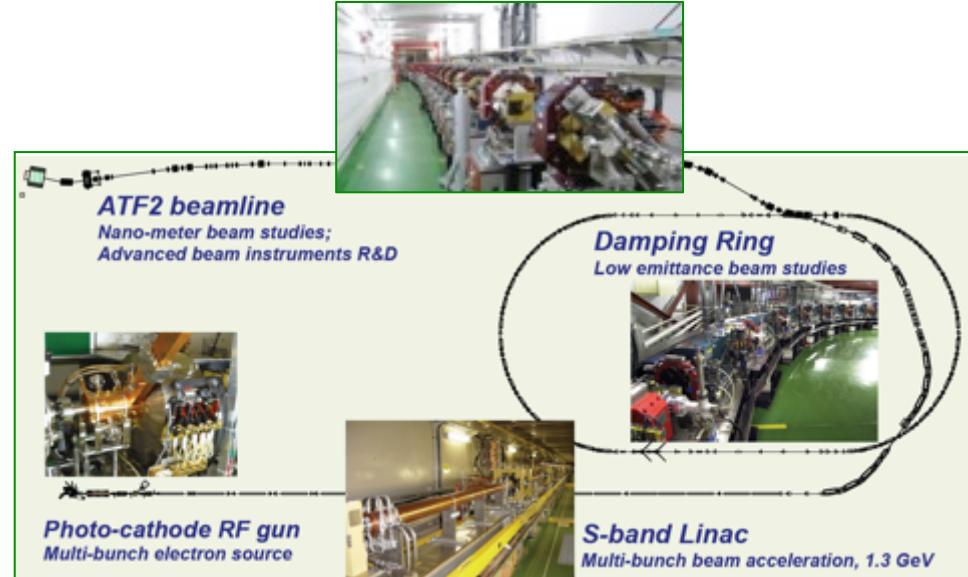
ATF2 Progress by 2013

2013年までの進展

Ultra-small beam

- Low emittance : KEK-ATF
 - 4 pm achieved
 - (ILC target value, in 2004).
- Small vertical beam size :
 - KEK ATF2
 - Goal = 37 nm,
 - 160 nm (spring, 2012)
 - 65 nm (April, 2013) at low beam current

$$\mathcal{L} = f_{rep} \frac{n_b N^2}{4\pi \sigma_x^* \sigma_y^*} \times H_D$$



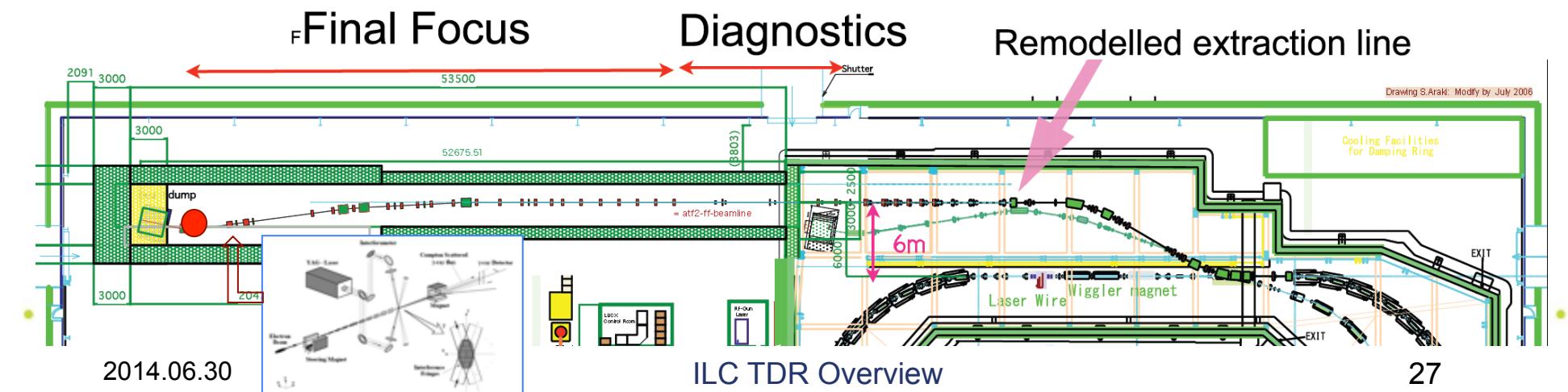
ナノビームによるルミノシティ向上 : KEK-ATFが国際協力の中心的役割



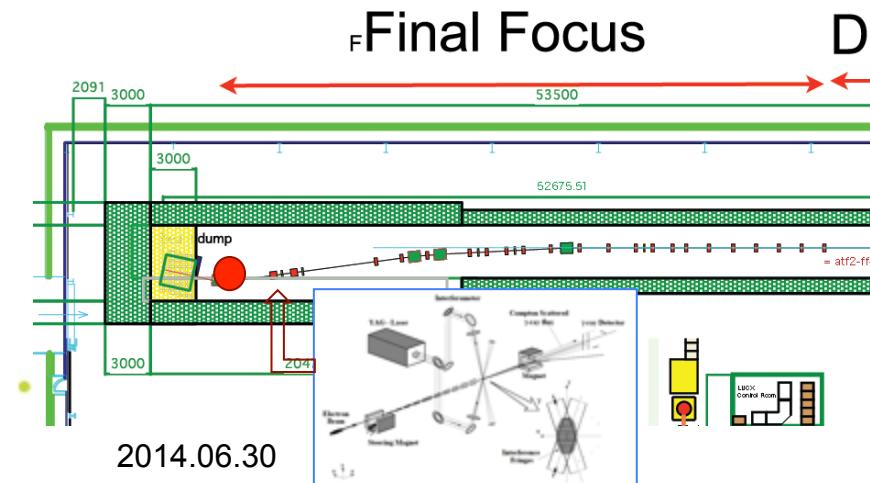
KEK-ATF2: BDS Test Facility for ILC

ILC 最終収束モデル化・ナビーム技術検証

- Modeling of ILC BDS
 - Same Optics: ILCと同じ光学
 - Int'l Collab. (国際協力)
- ~25 Lab. , > 100 Collaborators
- Goal:
FF Beam Size: 37 nm
 - (ILC で5.9 nm に相当)



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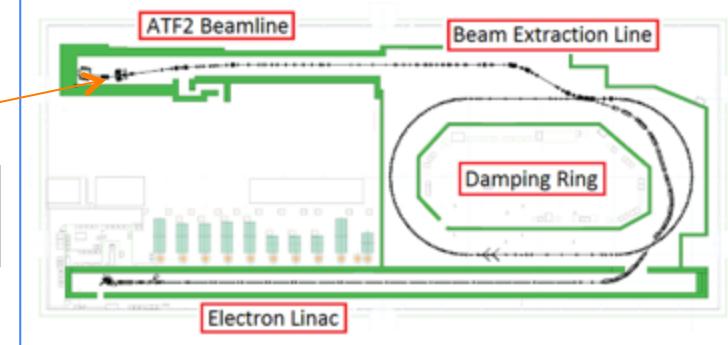
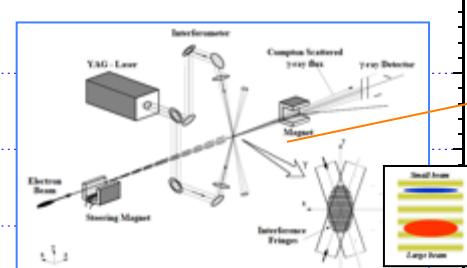
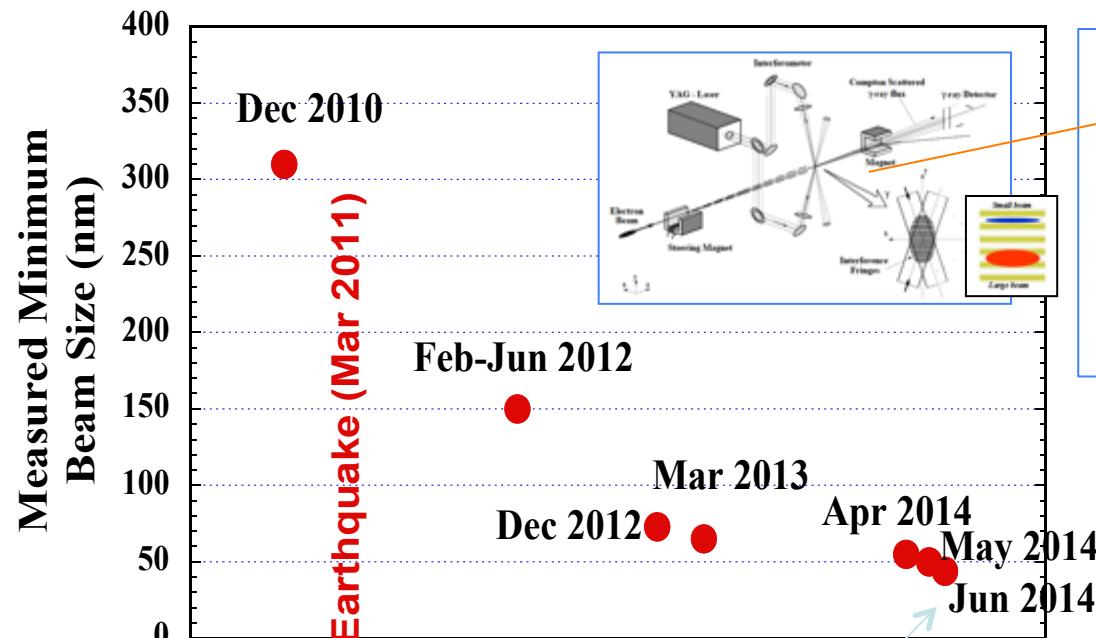


Parameter	ILC	ATF2
Beam Energy [GeV]	250	1.3
Energy Spread (e^+/e^-) [%]	0.07/0.12	0.06~0.08
Final quad – IP distance (L^*) (SiD/ILD detector) [m]	3.5/4.5	1.0
Vertical beta function at IP (β_y^*) [mm]	0.48	0.1
Vertical emittance [pm]	0.07	12
Vertical beam size at IP (s_y^*) [nm]	5.9	37
L^*/β_y^* (~natural vertical chromaticity, SiD/ILD detector)	7300/9400	10000

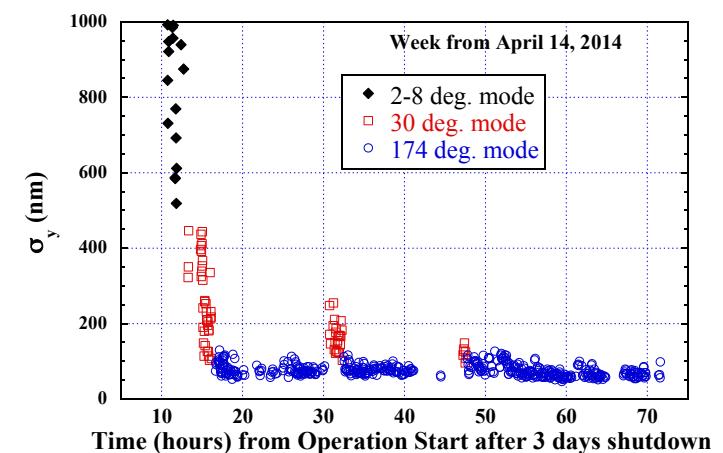


Progress in measured min. beam size at ATF2

2014年の進展（目標達成まで、あと一歩！）

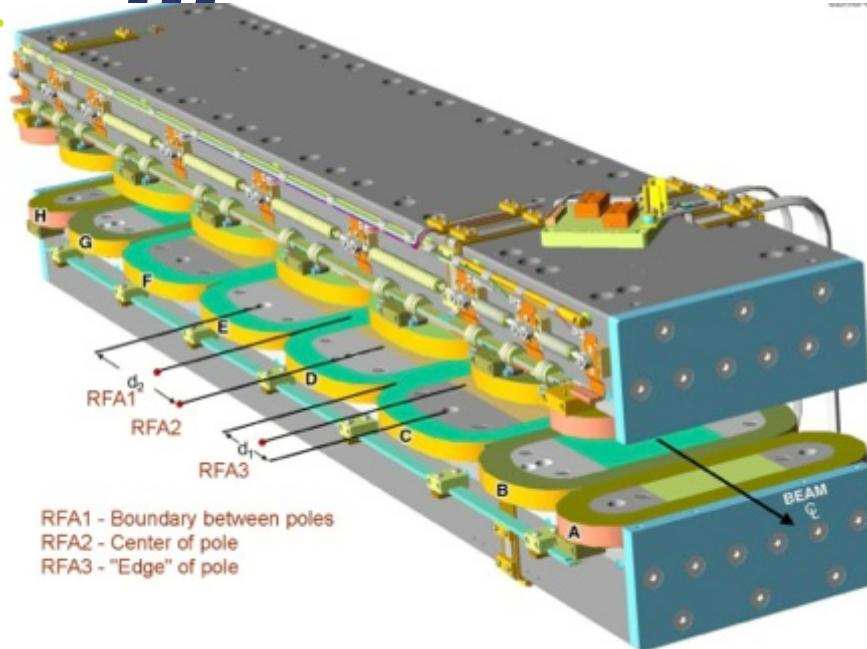


Beam Size 44 nm observed,
(Goal : 37 nm)

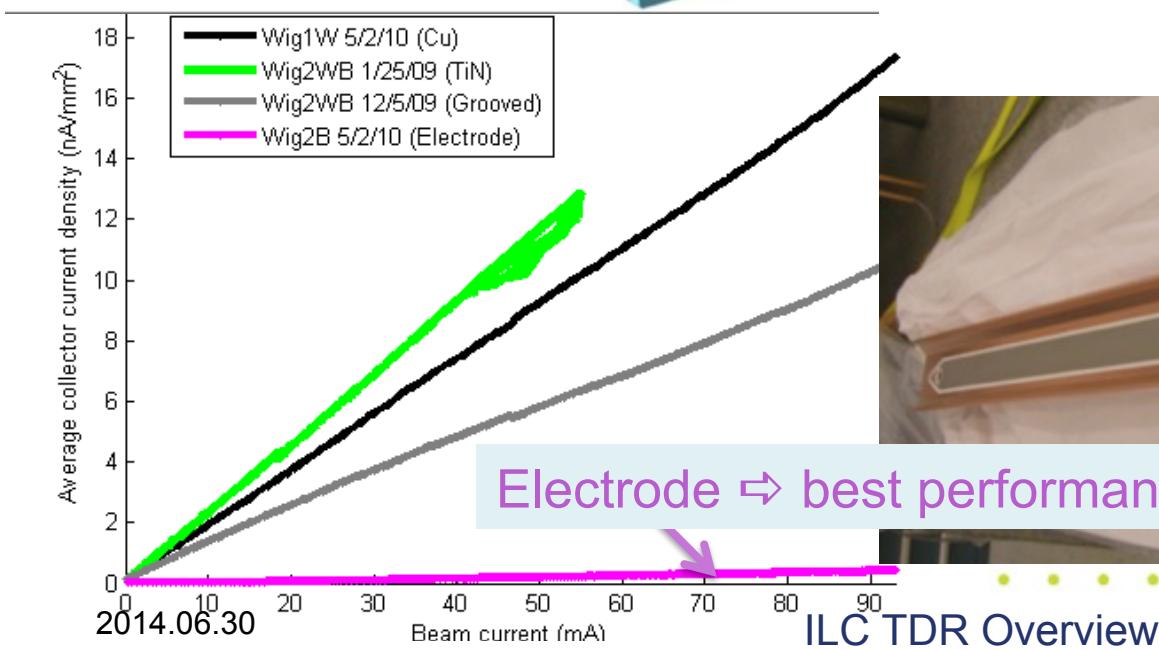
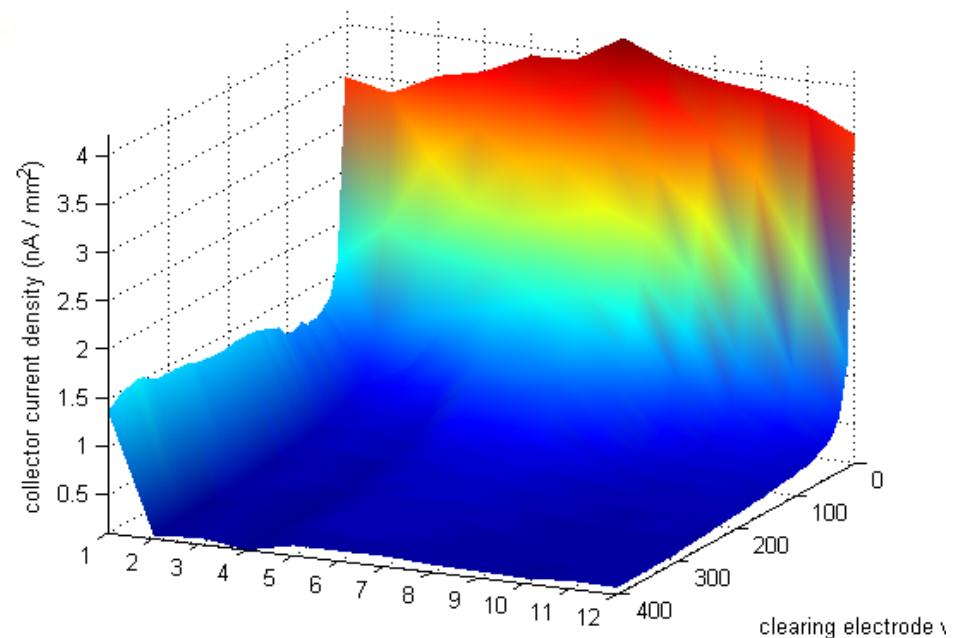


:lc

CesrTA - Wiggler Observations



Run #2568 (1x20x2.8mA e+, 4 GeV, 14ns): 01W_G2 Center pole Col Curs





Baseline Mitigation Plan

EC Working Group Baseline Mitigation Recommendation				
	Drift*	Dipole	Wiggler	Quadrupole*
Baseline Mitigation I	TiN Coating	Grooves with TiN coating	Clearing Electrodes	TiN Coating
Baseline Mitigation II	Solenoid Windings	Antechamber	Antechamber	
Alternate Mitigation	NEG Coating	TiN Coating	Grooves with TiN Coating	Clearing Electrodes or Grooves

*Drift and Quadrupole chambers in arc and wiggler regions will incorporate antechambers

- Preliminary CESRTA results and simulations suggest the presence of *sub-threshold emittance growth*
 - Further investigation required
 - May require reduction in acceptable cloud density \Rightarrow reduction in safety margin
- An aggressive mitigation plan is required to obtain optimum performance from the 3.2km positron damping ring and to pursue the high current option



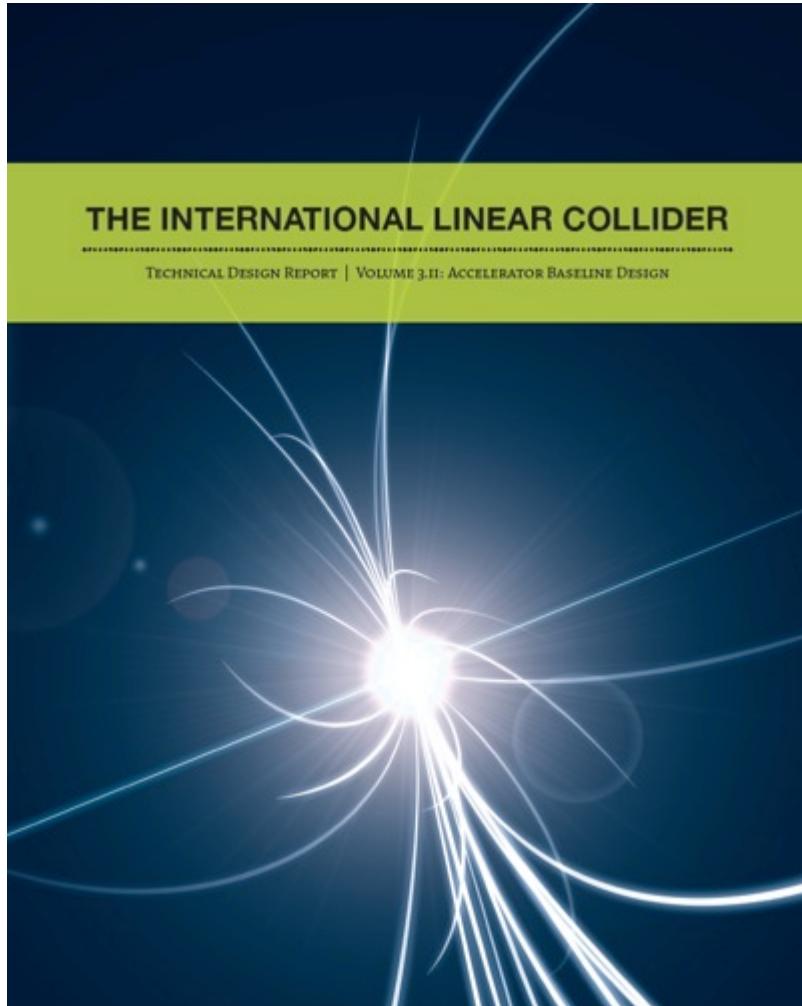
Outline

- Introduction
- Accelerator R&D
 - Accelerator Baseline Design,
- Detectors
- Energy Staging
- Schedule
- Summary



ILC TDR: Vol. 3-II Acc. Baseline Design

Vol. 3-II. 加速器基本設計

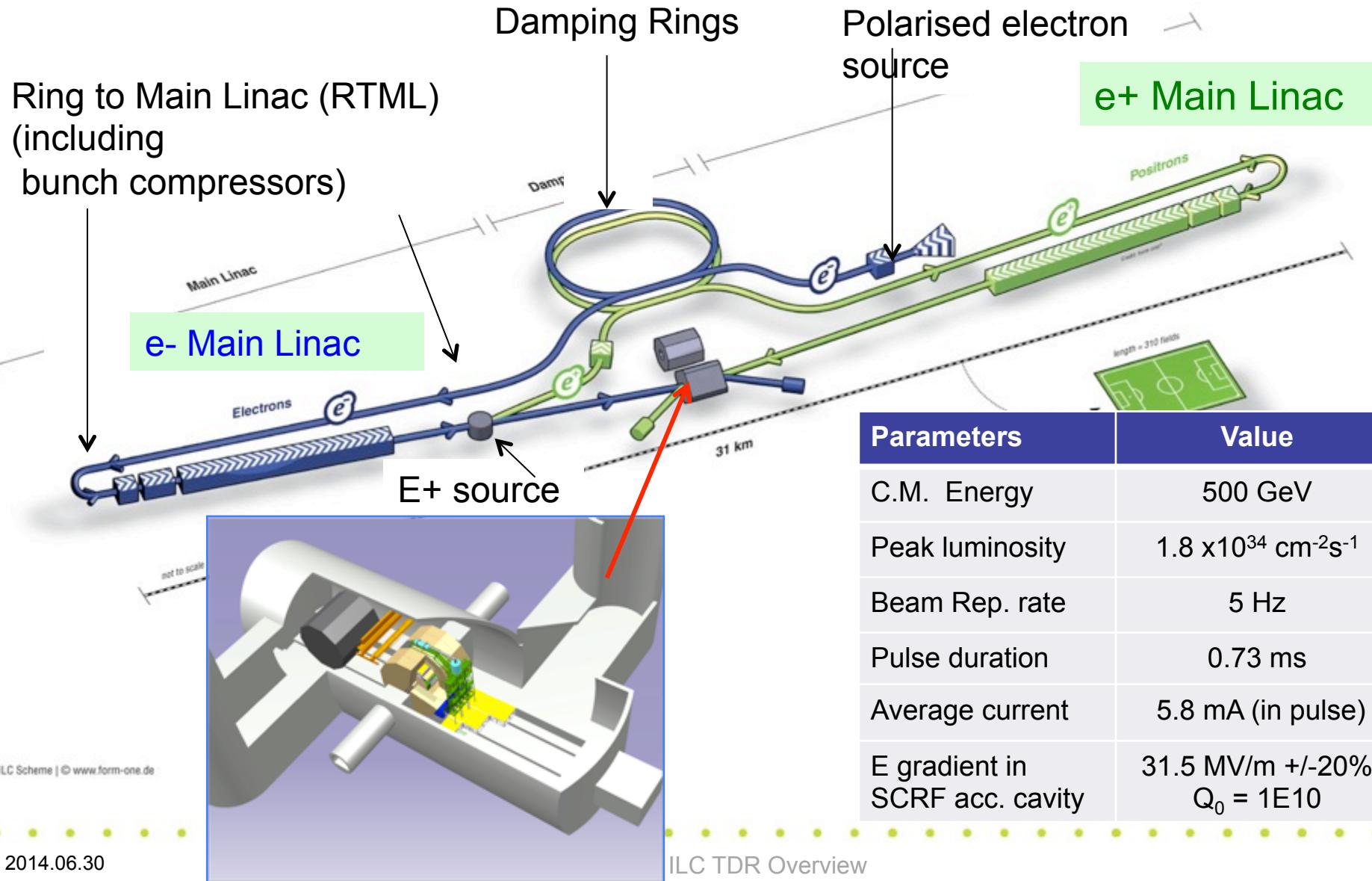


1. Introduction
2. General Parameters, Layout, System Overview → (山本)
3. Main Linac and SCRF Technology → (早野、道園)
4. Electron Source
5. Positron Source
6. Damping Rings (DR)
7. Ring to Main Linac (RTML)
8. Beam Delivery Sys. (BDS) & Machine Detect. Int. (MDI)
9. Global Accelerator Control Systems
10. Availability, Commissioning, and Operations
11. Conventional Facilities and Siting (CFS) → (榎本、宮原)
12. Possible upgrade and staging options
13. Project Implementation Planing → (山本)
14. Construction schedule
15. ILC TDR Value Estimate → (設楽)

A. Evolution of the ILC design in the TD Phase

- Detectors: → (藤井)

ILC TDR Layout





ILC Published Parameters

Centre-of-mass dependent:

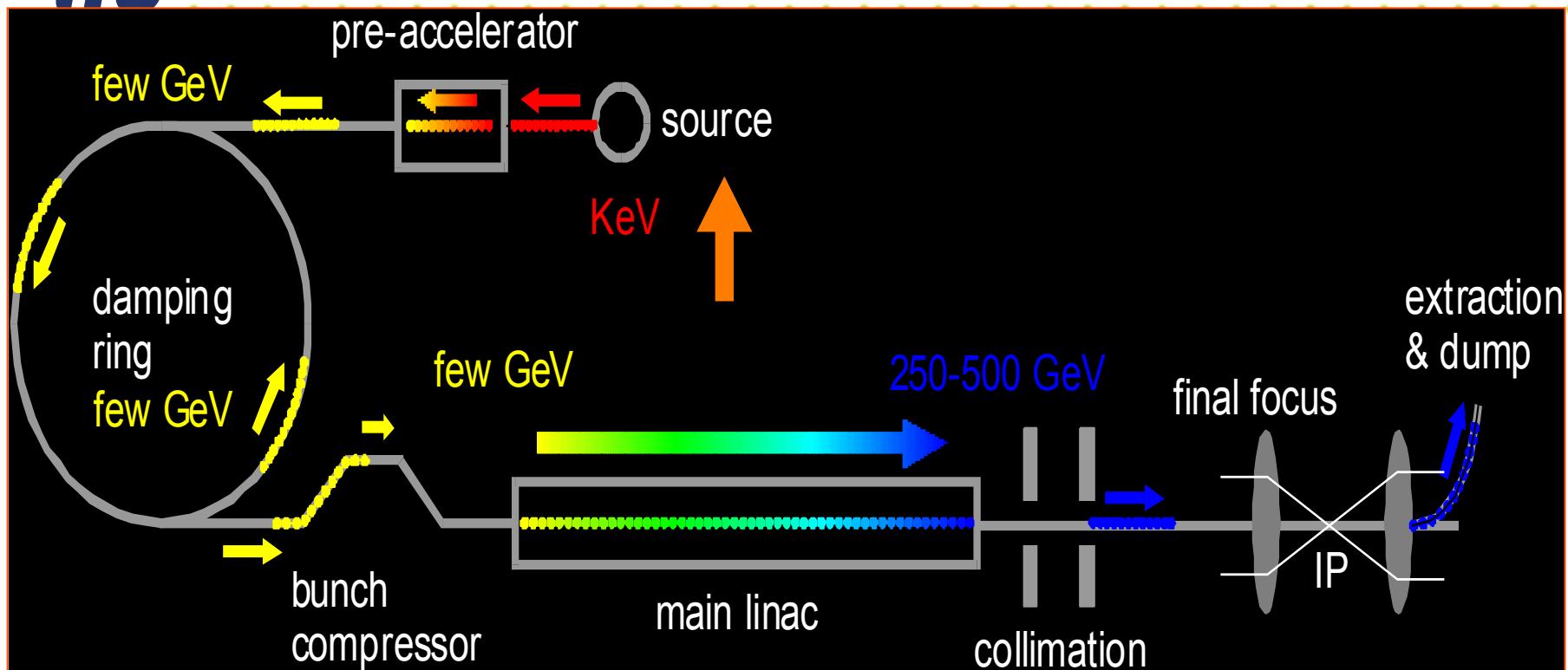
Focus of design (and cost!) effort

Centre-of-mass energy	GeV	200	230	250	350	500
Electron RMS energy spread	%	0.21	0.19	0.19	0.16	0.12
Positron RMS energy spread	%	0.19	0.16	0.15	0.10	0.07
IP horizontal beta function	mm	16	16	12	15	11
IP vertical beta function	mm	0.48	0.48	0.48	0.48	0.48
IP RMS horizontal beam size	nm	904	843	700	662	474
IP RMS vertical beam size	nm	9.3	8.6	8.3	7.0	5.9
Vertical disruption parameter		20.4	20.4	23.5	21.1	24.6
Enhancement factor		1.83	1.83	1.91	1.84	1.95
Geometric luminosity	$\times 10^{34} \text{ cm}^{-2}\text{s}^{-1}$	0.25	0.29	0.36	0.45	0.75
Luminosity	$\times 10^{34} \text{ cm}^{-2}\text{s}^{-1}$	0.50	0.59	0.75	0.93	1.8
% luminosity in top 1% $\Delta E/E$		92%	90%	84%	79%	63%
Average energy loss		1%	1%	1%	2%	4%
Pairs / BX	$\times 10^3$	41	50	70	89	139
Total pair energy / BX	TeV	24	34	51	108	344

<http://ilc-edmsdirect.desy.de/ilc-edmsdirect/item.jsp?edmsid=D00000000925325>



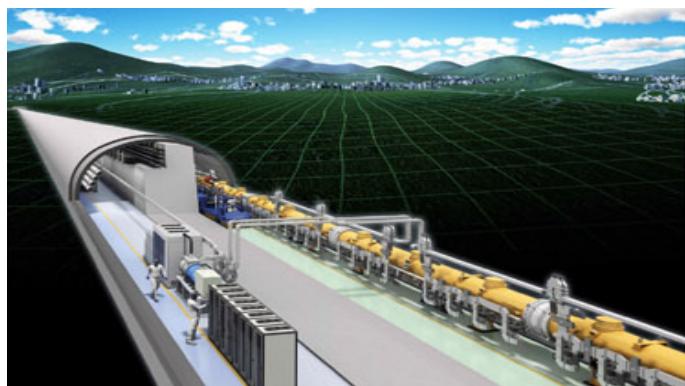
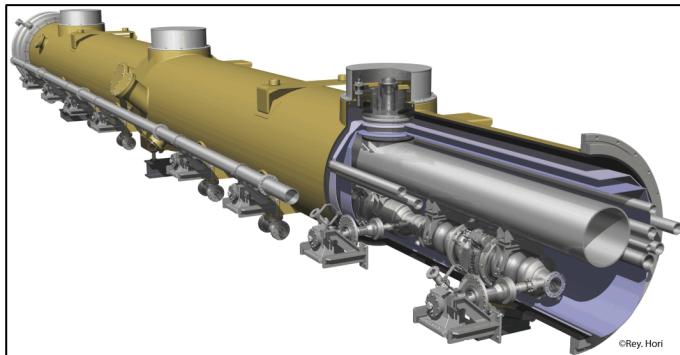
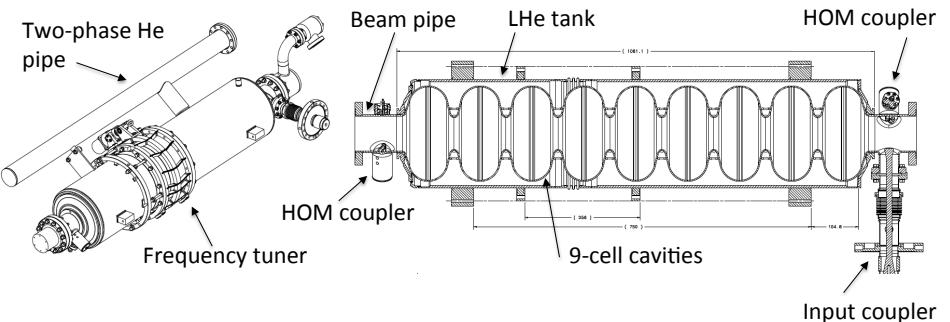
ILC Accelerator: Sub-Systems



- Electron and Positron Sources (e^- , e^+) : 電子・陽電子源
- Damping Ring (DR) : 減衰リング
- Ring to ML beam transport (RTML) : ビームトランスポート
- Main Linac (ML) : 主線形加速器 (超伝導加速技術)
- Beam Delivery System (BDS) : ビーム伝達・最終収束システム

SCRF Linac Technology

超伝導：線形加速器技術



2014.06.30

1.3 GHz Nb 9-cellCavities	16,024
Cryomodules	1,855
SC quadrupole pkg	673
10 MW MB Klystrons & modulators	436 / (471 *)

* site dependent

Approximately 20 years of R&D worldwide
→ Mature technology



SCRF Main Linac Parameters (500 GeV)

Characteristics	Parameter	Unit	Demonstrated
Average accelerating gradient	31.5 ($\pm 20\%$)	MV/m	DESY, FNAL, JLab, Cornell, KEK,
Cavity Q ₀	10 ¹⁰		
(Cavity qualification gradient	35 ($\pm 20\%$)	MV/m)	
Beam current	5.8	mA	DESY-FLASH, KEK-STF
Number of bunches per pulse	1312		
Charge per bunch	3.2	nC	
Bunch spacing	554	ns	
Beam pulse length	730	μs	DESY-FLASH, KEK-STF
RF pulse length (incl. fill time)	1.65	ms	DESY-FLASH, KEK-STF, FNAL-ASTA
Efficiency (RF → beam)	0.44		
Pulse repetition rate	5	Hz	
Peak beam power per cavity	190*	kW	* at 31.5 MV/m



Site Specific Design in RF Power

Distributed
Klystron
Scheme

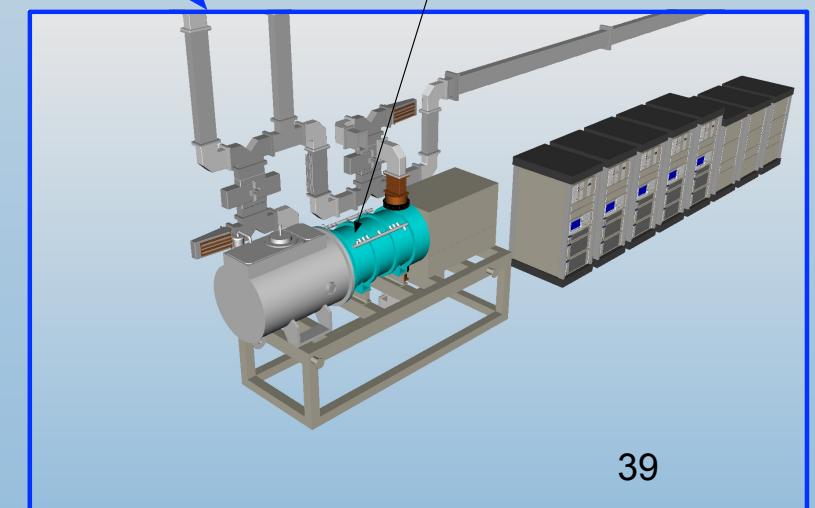
accelerator cryomodules

location of
upgrade klystron

WR770

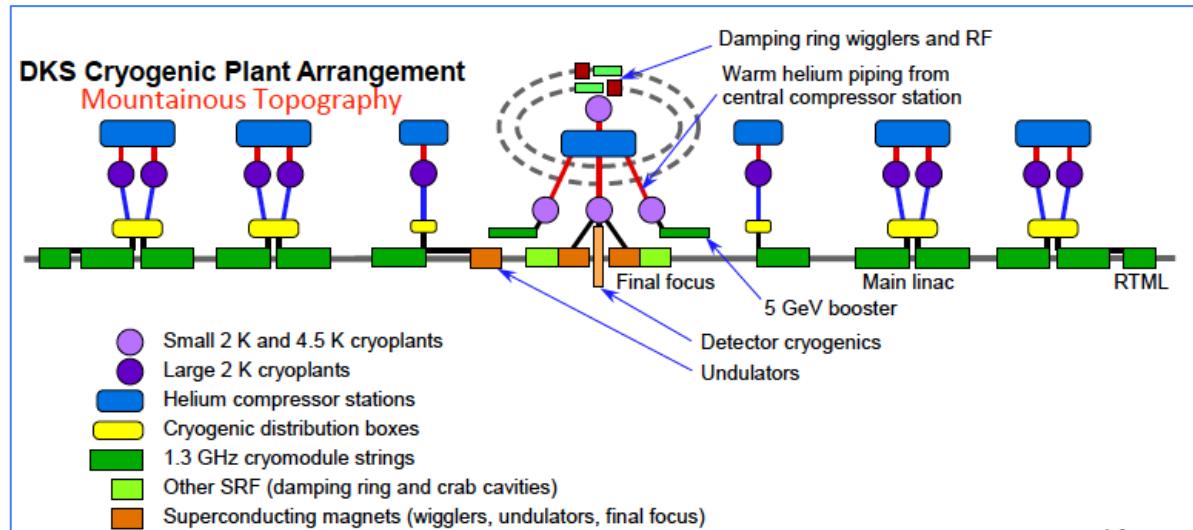
10 MW klystron

shield wall



ILC Cryogenic (TDR)

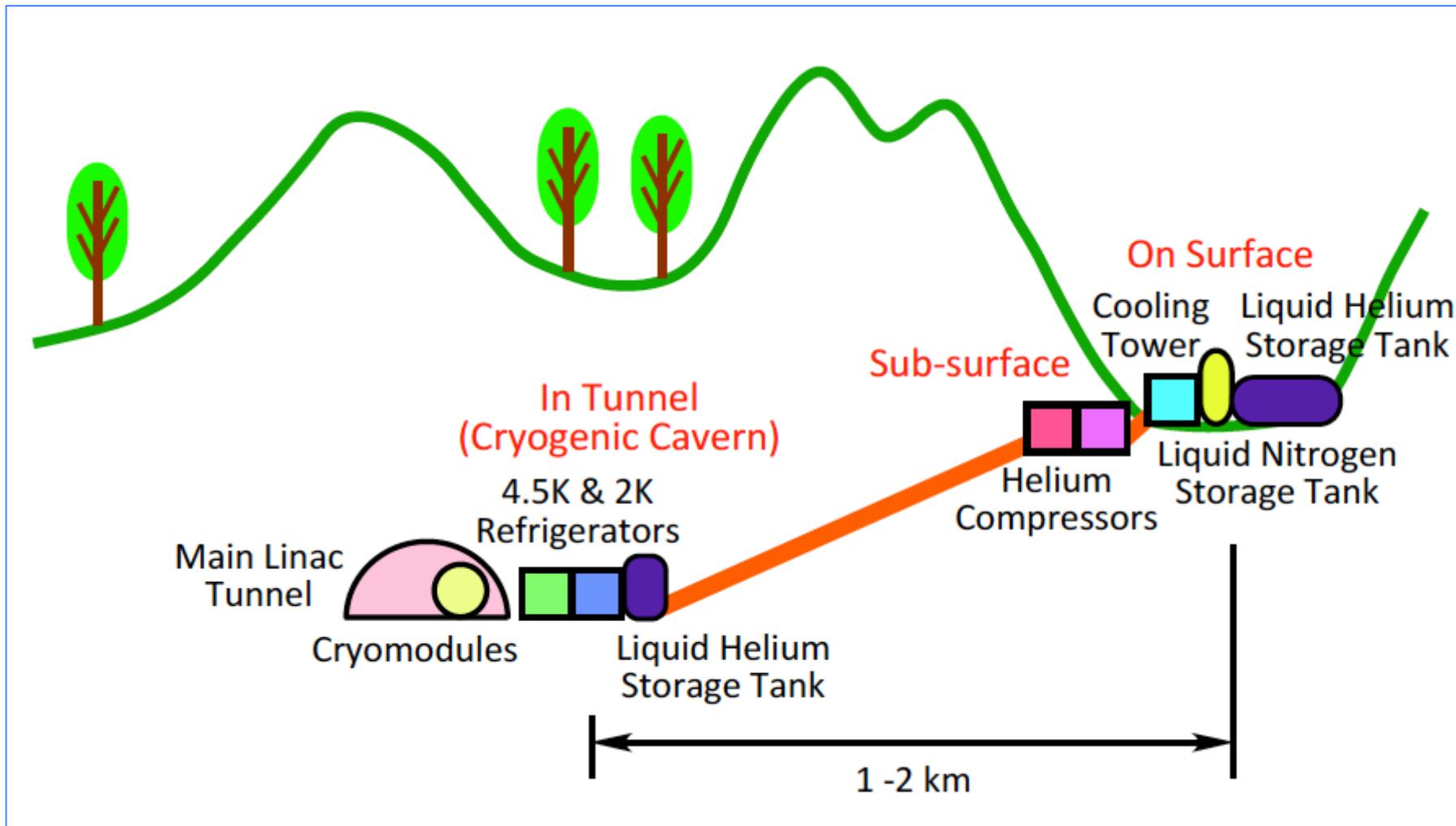
ILC 冷却システム



	40–80 K	5–8 K	2 K
Predicted module static heat load	(W/module)	75.04	10.82
Predicted module dynamic heat load	(W/module)	58.80	5.05
Number of cryomodules per cryogenic unit		156 / 189	156 / 189
Non-module heat load per cryo unit	(kW)	0.7 / 1.1	0.14 / 0.22
Total predicted heat per cryogenic unit	(kW)	21.58 / 26.40	2.61 / 3.22
Efficiency (fraction Carnot)		0.28	0.24
Efficiency in Watts/Watt	(W/W)	16.45	197.94
Overall net cryogenic capacity multiplier		1.54	1.54
Heat load per cryogenic unit including multiplier	(kW)	33.23 / 40.65	4.03 / 4.96
Installed power	(kW)	547/669	797/981
Installed 4.5 K equiv	(kW)	2.50 / 3.05	3.64 / 4.48
Percent of total power at each level		0.16	0.24
Total operating power for one cryo unit based on predicted heat (MW)		2.63 / 3.24	
Total installed power for one cryo unit (MW)		3.37 / 4.16	
Total installed 4.5 K equivalent power for one cryo unit (kW)		15.40 / 19.01	

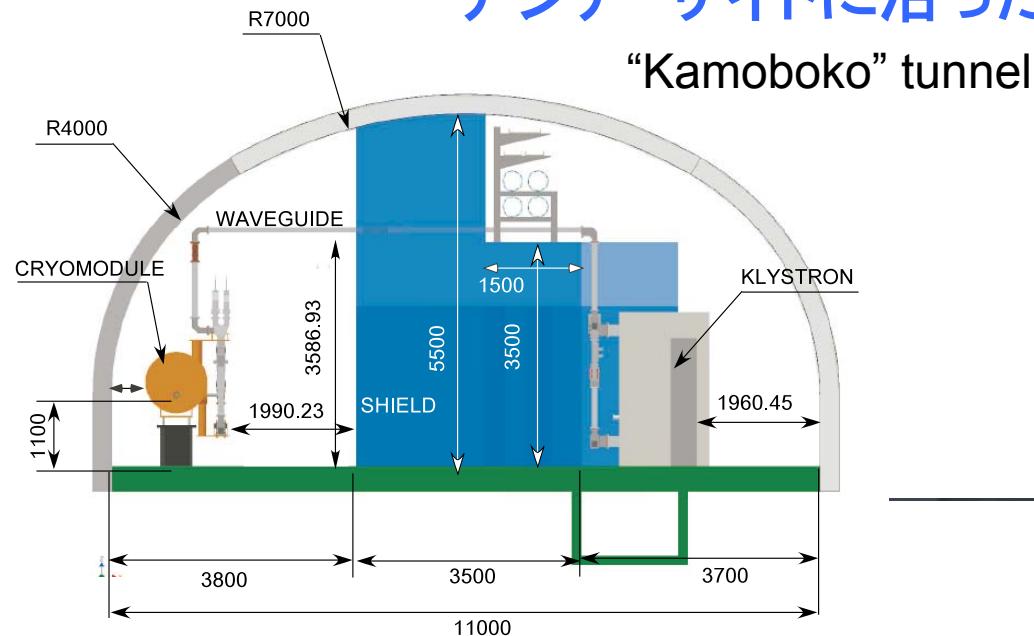


ILC Cryogenics Layout (After TDR)



Site Specific Design in CFS

アジア・サイトに沿った土木・建築設計



"Mountainous"
Topography site-
dependent design

→ To be reported by A. Enomoto, M. Miyahara

Reduced surface presence.

Horizontal access

Most infrastructure underground.

